High-gradient accelerator technology

Dr. ir. Xander Janssen

xander.janssen@vdletg.com



VDL Enabling Technologies Group

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VDL Enabling Technologies Group (ETG)



1900 Philips Machine Factories



1980 Also Non-Philips Customers



1990 Integrated Systems



2000 New name: Philips ETG



2006 ETG part of VDL Group

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Locations



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Core Technology Competences

Machining



- Modern turning and milling centers \checkmark
- Multi-axis complex geometry machining
- Joining technologies
- Advanced materials technology
- Vacuum technology
- Ultra precision technology



Engineering

- (Co-) Development and engineering
- Project management (Six Sigma, Prince 2)
- Design and product optimization (DFX)
- Sustaining of product documentation
- ✓ Access to Philips resources and Technical Campus
- Long-standing relationships with knowledge institutes

Sheet metal

- Modern sheet metal centers
- Complex frame production
- Vacuum and specific welding methods
- Production of covering including painting Advanced materials technology



Supply-chain management

- Supply chain control and optimization
- Flexibility
- Lead-time road-mapping and lead time reduction
- Break-even point reduction



System integration and assembly

Clean room and non clean room assembly Assembly of modules and complete systems Final test of complete systems and modules Process control and validation



Property right

- Intellectual property right protection
- Production under license



Core Technology Markets



Semiconductor Capital Equipment



Analytical Equipment





Medical Equipment



Turn Key Projects



Led Manufacturing Equipment



Solar Production Equipment



Science & Technology

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Competences for S&T - Manufacturing

Machining

✓ Single Point Diamond Turning

- Form accuracies < 0.1 μm
- Surface finish better than 5 nm Ra
- 2/3 axis and freeform capabilities

✓ Single Point Diamond Milling

- Form accuracies < 1 μm
- Surface finish better than 25 nm Ra
- Up to 5-axis capabilities
- Pallet machining of micron accuracy parts















Competences for S&T - Measuring

Metrology

- ✓ 3D- metrology
 - 3D CMM × 0.8 μm accuracy × low measuring force
 - Multi sensor CMM × camera / touch probe / laser

✓ Profilometry

- Surface finish measurements
- Form measurements (2D and 3D)

✓ Optical measurement techniques

- Surface finish and step heights
- Flatness (up to ø100) and form





Parts for SwissFEL

- ✓ X-band structure
 - All 4 structures delivered

✓ Gun

- Delivered currently under test
- Potential second as spare e.o. 2014

✓ BOC Pulse compressor

- Prototype delivered
- Series of 28 in-house by PSI

✓ J-couplers

- 7 prototype sets delivered
- Series production of 104 sets
- ✓ H-tassen
 - 1 prototype set delivered
 - Production of 4 more structures











Parts for CERN CLIC

- ✓ Octants for Power Extraction & Transfer Structure
 - Several structures delivered

✓ Disks for Acc.-structure

- Several prototype designs delivered
- 8 TD26 structures delivered

✓ High power loads

Several structures delivered

✓ RF-network components delivered

- Splitters
- Directional couplers
- Pumping ports
- Flanges









Drivers for Industry



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Improving existing machining techniques



Form	12 µm
Ra	50 nm
Length	500 mm



Form	2 µm
Ra Iris	5 nm
Ra Cross	25 nm

Diameter 80 mm



Form	5 µm
Ra	25 nm
Length 200 mm	

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From mono-parts to (sub)assemblies













CLIC at 500 GeV (4248 modules) 26312 Accelerating structures 13156 PETS ~ 70000 RF components

CLIC at 3 TeV (20924 modules) 142812 Accelerating structures 71406 PETS ~ 400000 RF components

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Develop / obtain new techniques

✓ Vacuum brazing

- Increasing number of steps
- Various brazing materials
- Complex geometries

✓ Hydrogen bonding

- Developed within science
- Promising for main stream
- Highly specialized equipment

✓ In-house RF testing

• Key for delivering entire RF-structures







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Drivers for Industry



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High Gradient Accelerator Spin-off

Proton therapy of tumors

- 5% of tumors not cured by classic radiotherapy
- Potentially cured by proton therapy



Free electron laser:

- Bright light source
- Wavelengths from infrared down to x-ray



Benefits for science

✓ Time to market

- Co-development & rapid proto typing
- Increased complexity requires higher level outsourcing



EUV light source : from idea to product in 1 year



CLIC (future): from cell over bonding to (ultimately) complete module

✓ Industrialization

- Early customer involvement
- Cost control & risk reduction
- Co / Redesign for manufacturability

Straight mode converter - from 16 to 2 parts

✓ Spin offs

- Increased market size for technologies \rightarrow Cost reduction
- Show public relevance of fundamental research \rightarrow Funding





Enabling your success in business...



